

PATENT APPLICATION

Docket No.: 119152

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshimitsu HIRAI

Application No.: 10/803,027

Filed: March 18, 2004

METHOD OF FORMING THIN FILM PATTERN, METHOD OF MANUFACTURING

DEVICE, ELECTRO-OPTICAL APPARATUS AND ELECTRONIC APPARATUS

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

Please consider the following:

Amendments to the Specification;

Remarks.